

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Ganguli et al.

Serial No.: 10/811,230

Confirmation No.: 8995

Filed: March 26, 2004

For: Ruthenium Layer Formation  
for Copper Film Deposition

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Group Art Unit: 1792

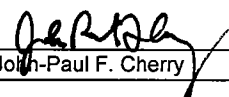
Examiner: Kelly M. Stouffer

MAIL STOP AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## CERTIFICATE OF TRANSMISSION

I hereby certify that this correspondence is being electronically transmitted to the U.S. Patent and Trademark Office via EFS-Web to the attention of Examiner Kelly M. Stouffer, on the date shown below.

January 14, 2008  
Date

  
John-Paul F. Cherry

Dear Sir:

## REQUEST FOR CONTINUED EXAMINATION

This Request for Continued Examination is in response to the Final Office Action dated October 16, 2007, having a shortened statutory period for response set to expire on January 16, 2008, please enter this Request and reconsider the claims pending in the application for reasons discussed below. The attached RCE Transmittal provides the Commissioner with authority to charge the Applicant for the required fees. However, if any additional fees are due in connection with this Request, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005975.P2/JPC, to make this Request timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of this paper. **Amendments to the Claims** begin on page 3 of this paper. **Remarks** begin on page 15 of this paper.